

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: John Commander, et al.
Art Unit: 1753
Serial No.: 10/091,106
Filed: March 5, 2002
Confirmation No.: 5919
For: DEFECT REDUCTION IN ELECTRODEPOSITED
COPPER FOR SEMICONDUCTOR APPLICATIONS
Examiner: Edna Wong

June 5, 2006

REQUEST FOR CONTINUED EXAMINATION TRANSMITTAL

TO THE COMMISSIONER FOR PATENTS,

SIR:

This is a Request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the above-identified application.

1. REQUIRED SUBMISSION:

- a. ☐ Previously submitted
 - i. ☐ Consider the amendment(s)/reply under 37 C.F.R. §1.116 previously filed on _____
 - ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
 - iii. ☐ Other _____
- b. ☒ Enclosed
 - i. ☒ Amendment G After Final
 - ii. ☐ Affidavit(s)/Declaration(s)
 - iii. ☐ Information Disclosure Statement
 - iv. ☐ Other _____

2. MISCELLANEOUS

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. §1.103(c) for a period of _____ months. (Period of suspension shall not exceed 3 months; fee required)
- b. ☐ Other _____

3. FEES (Required when the RCE is filed)

- a. ☒ The Director is hereby authorized to charge the following fees, or credit any overpayments, to Deposit Account No. 19-1345.

(\$790) i. ☒ RCE fee required under 37 C.F.R. §1.17(e)

ii. ☒ Extension of time fee (\$450)

iii. ☐ Other _____

b. ☐ Check in the amount of \$_____ is enclosed. The Commissioner is hereby authorized to charge any underpayment or credit any overpayment to Deposit Account No. 19-1345.

Respectfully submitted,

/Paul I. J. Fleischut/

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